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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ruvin Deych et al.

Examiner:

Serial No.:

10/814,992

Group Art Unit: 2878

Filing Date:

March 31, 2004

Docket Number:

56229-153 (ANA-248)

Title:

DYNAMIC EXPOSURE CONTROL IN RADIOGRAPHY

## CERTIFICATE OF MAILING PURSUANT TO 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Date:

Gayle Endres / DAM is

**Commissioner for Patents** 

P.O. Box 1450

Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants and their attorney are aware of the following publications and information, listed on the attached Form PTO-A820, and in accordance with 37 CFR §1.97 hereby submit these publications for the Examiner's consideration. This Statement is being filed more than three months after the filing date of the application, but before the receipt of any Official Action from the Patent and Trademark Office. A full copy of each cited publication is enclosed.

This statement is not to be interpreted as a representation that the cited publications are material, that an exhaustive search has been conducted, or that no other relevant information exists. Nor shall the citation of any publications herein be construed *per se* as a representation that such publications are prior art. Moreover, the Applicants understand that the Examiner will make an independent evaluation of the cited publications.

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No additional costs are believed to be due in connection with the filing of this Information Disclosure Statement. If, however, a first Office Action on the merits issues in this application bearing a mailing date prior to the date of this Information Disclosure Statement, please charge any necessary fees to our Deposit Account No. 50-1133.

Respectfully submitted,

Elizabeth E. Kim

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Date: August 6, 2004

Docket Number (Optional) Application Number 56229-153 (ANA-248) 10/814,992 AATION DISCLOSURE CITATION

(Use several sheets if necessary) Applicant(s) Ruvin Deych et al. Filing Date Group Art Unit March 31, 2004 2878 **U.S. PATENT DOCUMENTS** FILING DATE DOCUMENT NUMBER DATE NAME CLASS SUBCLASS INITIAL IF APPROPRIATE 6,594,337 07/15/03 Silver et al. 378 85 6,618,090 09/09/03 Kidono et al. 348 362 6,754,307 06/22/04 Brendler et al. 378 108 U.S. PATENT APPLICATION PUBLICATIONS \*EXAMINER FILING DATE SUBCLASS REF DOCUMENT NUMBER DATE NAME CLASS INITIAL IF APPROPRIATE FOREIGN PATENT DOCUMENTS Translation SUBCLASS CLASS COUNTRY REF DOCUMENT NUMBER DATE OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) DATE CONSIDERED **EXAMINER** EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-A820 (also form PTO-1449)

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